

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**  
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.  
S111-USA

In Re Application Of: Greenberg, et al.

Serial No.  
*OK*  
10/064,458

Filing Date  
10/26/2001

Examiner  
unknown

Group Art Unit  
unknown

Title: **IMPLANTABLE MICROFLUIDIC DELIVERY SYSTEM USING ULTRA-NANOCRYSTALLINE DIAMOND COATING**

Address to:  
Assistant Commissioner for Patents  
Washington, D.C. 20231

**37 CFR 1.97(b)**

1. ☒ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

**37 CFR 1.97(c)**

2. ☐ The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

☐ the statement specified in 37 CFR 1.97(e);

**OR**

☐ the fee set forth in 37 CFR 1.17(p).

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**IMPLANTABLE MICROFLUIDIC DELIVERY SYSTEM USING ULTRA-NANOCRYSTALLINE  
COATING**

**Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. **50-0922** as described below. A duplicate copy of this sheet is enclosed.
- ☐ Charge the amount of \_\_\_\_\_
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.

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**Certificate of Mailing by First Class Mail**

I certify that this document and fee is being deposited  
March 7, 2002 with the U.S. Postal Service  
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Emily M. Stuart

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Signature

Gary D. Schnittgrund, Reg. No. 42,130  
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(661) 775-1595 fax

Dated: 3/7/02

CC:

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Document Number (Optional)

S11

Application Number

10/064,458

Applicant(s)

Greenberg, et al.

Filing Date

10/26/01

Group Art Unit

unknown

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		4,991,582	2/12/91	Byers, et al.			
		5,750,926	5/12/98	Schulman, et al.			
		5,797,898	8/25/98	Santini, Jr. et al.			
		6,123,861	9/26/00	Santini, Jr. et al.			

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		D.M. Zhou, et al., "Accelerated Corrosion Tests on Silicon Wafer for Implantable Medial Devices", Proc. of 198th Electrochemical Society Meeting, 363, October 2000
		D.M. Gruen, "Nanocrystalline Diamond Films" Annu. Rev. Mater. Sci., 29 211-59 (199)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

S11

Application Number

10/046458

Applicant(s)

Greenberg, et al.

Filing Date

10/26/2001

Group Art Unit

unknown

\*EXAMINER  
INITIAL

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

D.M. Gruen, et al. "Buckyball Microwave Plasmas: Fragmentation and Diamond Film Growth", J. Appl. Phys., 75 (3) 1758-63 (1994)

EXAMINER

DATE CONSIDERED

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